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Attorney's Docket No. 5649-921

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Kim et al.  
Serial No.: 10/601,475  
Filed: June 23, 2003

Group Art Unit: 2811  
Examiner: To Be Assigned  
Confirmation No.: 7249

For: SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES THAT  
FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE  
CONTAMINATION AND METHODS OF FORMING SAME

Date: November 29, 2005

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

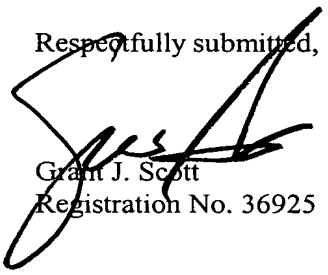
**SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Sir:

Attached is a Second Supplemental Form PTO-1449 listing documents cited in an Office Action for corresponding German Application Number 103 37 757.3-33. Each document listed on the attached PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of any listed foreign patent document and/or non-patent literature including the Office Action, is enclosed.

It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. §1.56 and Section 609 of the MPEP. No fee is believed due; however, the Commissioner is hereby authorized to charge any deficiency or credit any refund to Deposit Account No. 50-0220.

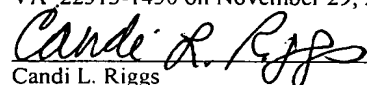
Respectfully submitted,

  
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**Certificate of Mailing under 37 CFR 1.8**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 29, 2005.

  
Candi L. Riggs

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.